

~~CONFIDENTIAL~~
Office Memorandum UNITED STATES GOVERNMENT

TO : Chief, Geographic Research, ORR

FROM : Chief, Cartography Division, ORR

SUBJECT: Attendance at Professional Meetings, FY 1961

DATE:

The following are estimates for D/GC attendance at professional meetings during FY 1961:

<u>Organization</u>	<u>Place</u>	<u>Dates</u>	<u>Number of Persons</u>	
			<u>Full Agency Sponsorship</u>	<u>Duty status w/o reimbursement for travel cost</u>
International Design Conference	Aspen, Colo.	June 1961 8 days	1	0
Seminar in Graphics (Tecnifax Corp.)	Holyoke, Mass.	Fall 1960 & Spring 1961 3 days each	2	0
Assoc. for Asian Studies	Chicago, Ill.	April 1961 4-5 days	2	0
African Studies Assoc.	Eastern U.S.	Unknown 4 days	2	0
Am. Congress for Surveying & Mapping	Wash., D. C.	March 1961	0	25
Middle East Institute	Wash. D. C.	Spring 1961 25X1A9a	0	1



Distribution:
Orig. & 3 - Addressee
2 - D/GC/RR
D/GC/RR: [redacted] :hjm/4071
25X1A9a

~~CONFIDENTIAL~~

Sanitized - Approved For Release :
CIA-RDP63-00314R000100340003-3

List of Travel to Professional Meetings

FY 1961

<u>Professional Society or Organization</u>	<u>Location of Meetings</u>	<u>Inclusive Dates of Attendance</u>	<u>Number of Personnel to Attend</u>	
			<u>Sponsored</u>	<u>Duty Status</u>
12th General Assembly, IUGG	Helsinki, Finland	26 July - 6 Aug 60	2	
10th General Assembly, IGU	Stockholm, Sweden	5-16 Aug 60	5	4
Association for Asian Studies	Chicago, Illinois	3 days in Apr 1961	3	
African Studies Association	Eastern United States	Unknown; approximately 4 days' duration	2	
Institute of Navigation	Eastern United States	Unknown, approximately 4 days' duration	1	

~~SECRET~~

~~SECRET~~

Sanitized - Approved For Release :
CIA-RDP63-00314R000100340003-3